

22124



IN THE U.S. PATENT AND TRADEMARK OFFICE

Inventor Carlo MISIANO et al

Patent App. 10/066,329

Filed 31 January 2002

For METHOD OF AND APPARATUS FOR THIN FILM
DEPOSITION, ESPECIALLY UNDER REACTIVE
CONDITIONS

Art Unit 1734

Examiner Chen, B
Conf. No. 9829

Hon. Commissioner of Patents
Washington, DC 20231

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FIRST AMENDMENT

This is in response to the Office Action (paper 5) mailed 14 March 2003.

REMARKS

Pursuant to the requirement for restriction, Applicants provisionally elect the invention classified in Group I to which claims 1 to 7 and 19 are directed.

The restriction requirement is respectively traversed.

The Examiner contends that the two groups of claims are separate and distinct because the apparatus as claimed can be used

position.